



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Saka et al.

Application Number: **10/029,080**

Filed: **December 21, 2001**

For: **In-Situ Method and Apparatus
for End Point Detection in
Chemical Mechanical Polishing**

Group Art Unit: **2877**

Examiner: **M. P. Stafira**

CERTIFICATE OF MAIL (37 CFR 1.8(a))

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 on September 18, 2003.

Signed: _____

Lori Cox

RESPONSE/AMENDMENT

Commissioner for Patent
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant has considered the Office Action mailed April 18, 2003 in the above-captioned application and requests reconsideration of the claims in light of the amendments and remarks that follow. Accompanying this amendment is a Petition for Extension of Time under 37 CFR § 1.136(a) extending the period for response by two months, to and including Thursday, September 18, 2003.

Amendments to the Claims are reflected in the listing of claims which begin on page 2 of this paper.

Remarks begin on page 7 of this paper.

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